



IFW

PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Batch/Confirmation No.: 2788

Toshihiko TSUJI et al.

Allowed: February 1, 2005

Group Art Unit: 2851

Application No.: 10/603,807

Examiner: H. Nguyen

Filed: June 26, 2003

Docket No.: 116370

For: EXPOSURE METHOD AND EXPOSURE APPARATUS

LETTER TO THE OFFICIAL DRAFTSPERSON

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please substitute the attached 4 sheets of formal drawings depicting Figures 1-4 for the corresponding facsimile copy drawings filed with the application.

Respectfully submitted,

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MAC:MMI/ccs

Date: February 24, 2005

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